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A 3-D Model of Circuit Board Internal Electrostatic Charging

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Purpose:

Calculate potentials, energy storage, and discharge characteristics due to ungrounded metal traces on circuit boards exposed to the Jupiter Europa Orbiter (JEO) concept radiation environment for future use in deriving **IESD** design guidelines

Approach:

Calculate potentials and charge distribution due to penetrating electrons including conduction and plasma arc currents.



Top view of a typical circuit board showing dielectric board material (green), metal traces (silver), and assorted circuit components



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Jupiter Europa Orbiter (JEO) Concept



• JEO is the NASA element of the Europa Jupiter System Mission

It is designed to follow-up on the major discoveries of the Galileo and Voyager missions at Europa, especially its ocean. JEO would be built to withstand the intense radiation in Europa orbit, and would consist of an orbiter with 11 science instruments designed for extensive mapping of Europa. On the way to Europa, JEO would tour the Jovian system and make routine and frequent observations of Jupiter, its satellites and its environment.

Science Overview

Within the context of the EJSM themes and objectives, JEO would focus on its sub-goal: Explore Europa to investigate its habitability. While the primary focus of JEO is to orbit Europa, the science return encompasses the entire Jovian system, especially as is relevant to Europa's potential habitability. JEO uniquely includes flybys of Io and Europa, and includes flybys of Ganymede and Callisto, along with ~ 2.5 years observing Jupiter's atmosphere, magnetosphere, and rings.

• Mission Overview

JEO would launch in February 2020 on an Atlas V 551 and, using a ballistic trajectory with Venus-Earth-Earth gravity assists (VEEGA), arriving at Jupiter in December 2025. Jupiter Orbit Insertion (JOI) begins a 30 month Jovian system tour followed by a 9 month science mapping phase after Europa Orbit Insertion (EOI) in July 2028. The orbiter would ultimately impact the surface of Europa after succumbing to radiation damage or running out of orbit maintenance fuel.

from the JPL Outer Planet Flagship Mission website: opfm.jpl.nasa.gov



• Paper published 27 years ago

Philip L. Leung, Gregory H. Plamp, and Paul A. Robinson, Jr., "Galileo Internal Electrostatic Discharge. Program", Space Environmental Interactions Technology 1983, NASA Conference Publication 2359, AFGL-TR-0018, pp 423-425

• Data

Charged circuit boards using high energy electrons generated in JPL's Dynamitron facility

Circuit boards had grounded and ungrounded metalized traces

Measured characteristics of pulses carried by grounded leads

• Concerns

Mono energetic, high current environment

- Currents measured in leads, not on the boards
- Plan to extrapolate results to JEO Environment including shielding Circuit board geometry Proximity to ground plane



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Code Test Cases Based on Galileo ESD Paper

• Experimental Setup

Stainless steel75 micron(diffuser)50 micronAluminum plate50 micron(plasma current collector) $Cu 2 \text{ oz/ft}^2$ Cu 2 oz/ft²68 micronFR4 board thickness1.6 mm

• Electron Beam

Energy0.85 - 1.75 MeVCurrent Density $4 - 26 \text{ pA/cm}^2$

 Results (measured across 50 Ω resistor to ground) Small amplitude transients early (<1 V, < 20ns) After 2-4 hrs larger transients (>5 V)



Figure 1. - Target chamber and fixtures.

GALILEO INTERNAL ELECTROSTATIC DISCHARGE PROGRAM*

Philip L. Leung, Gregory H. Plamp, and Paul A. Robinson, Jr. Jet Propulsion Laboratory California Institute of Technology Pasadena, California 91109



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Circuit Board Layouts in the Galileo Tests







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What Happens During a Discharge

- Discharge creates a local plasma
- Only a small amount of charge is affected if plasma is contained inside the dielectric (Grounded Surface)
- Charge from large areas can contribute if plasma cloud can propagate in space (Floating dielectric surface)
- In either case, current appears on nearby conductors due to the redistribution of image charges



Fig. 5: Plasma cloud in the vacuum associated with discharge pulse and its tree.

A. R. Frederickson, "Electric Discharge Pulses In Irradiated Solid Dielectrics In Space", IEEE Transactions on Electrical Insulation Vol. EI-18 No.35 June 1983, 337



Smaller Pulses: Electron Flow to Ground

- Beam electrons charge "element" negative
- Arc makes low impedance path between "element" and nearby trace
- Small pulse involves electrons flowing from the "element" to the nearby trace
- Negative voltage indicates electrons flowing through the resistor to ground





Figure 3. - An intermediate discharge pulse observed during electron beam irradiation of circuit boards with floating circuit trace. Detector is a nearby grounded trace.





Space Administration Jet Propulsion Laboratory Larger Pulses: Electrons Flow to Plasma Current Collector

- Plasma Cloud Discharges negative dielectric
- Electrons trapped in dielectric flow to ground through Plasma Current Collector Resistor resistors (negative voltage)



Figure 1. - Target chamber and fixtures.







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Previous 1-D IESD Codes

• NUMIT (NUMerical InTegration) code

Developed by A. R. Frederickson

Developed by AFRL & later maintained by NASA

Documented in Insoo Jun, Henry B. Garrett, Wousik Kim, Joseph I. Minow, "Review of an Internal Charging Code, NUMIT", IEEE Transactions On Plasma Science, Vol. 36, No. 5, October 2008, p. 2467-2472

1-D charging calculations also in 1-D slab geometry

Allows only a single shield material, aluminum, and a single dielectric layer.

Uses analytical fits to published Monte Carlo electron deposition profiles to model the energetic particle transport. T

limits accuracy, especially for the substantial shielding required in harsh radiation environments such as Jupiter, and in multilayer components, such as circuit boards, where charge buildup frequently occurs at material interfaces.

SAIC group developed a Java version of NUMIT that also handles 1-D cylindrical geometry.

Code is part of NASA's Space Environment Effects Interactive Charging Handbook, and is limited to Earth orbiting spacecraft.

The cylindrical capability enables the modeling of coaxial cables, but only for the special case of omni-directional, isotropic radiation, and not for the mono-energetic, single direction beams used in laboratory testing.

JPL has a version of the SAIC code that allows user defined spectra, such as Jupiter radiation belt models, but only in the steady state limit.

• DICTAT (DERA Internal Charging Threat Assessment Tool)

D.J. Rodgers, K.A. Ryden, G.L. Wrenn, P.M. Latham, J. Sørensen, L. Levy,"An Engineering Tool for the Prediction of Internal Dielectric Charging", 6th Spacecraft Charging Technology Conference, September 2000, pp. 125-130

Developed for ESTEC by DERA and ONERA/DESP

1-D slab and cylindrical geometries

Very similar to NUMIT, but for electron transport. DICTAT adds a finite width to a simple, algebraic, electron range formula and ignores angular scattering, backscatter, secondary electrons, photon electrons

Incorporated into European Space Agency (ESA) Space Environment Information System (SPENVIS)



CB_IESD Code Designed to Extrapolate Lab Data to Jupiter Radiation Environment

- Geometry
 - 3-D Cartesian
 - Test chamber
 - Single circuit board
 - Traces
 - two or more
 - grounded and floating
- Charge deposition from 1-D Monte Carlo electron transport calculations using TIGER
- Calculations of time dependent potentials from Poisson's equation (spacecharge) and Ohm's law (conduction)
- Boundary Conditions on traces
 - Fixed potential (e. g. grounded)
 - Floating Potential Total charge
 - Traces assumed to be thin compared with circuit board
- Output
 - Electric potentials, fields, and charges on traces



Basic equations: charge continuity, Ohm's law and Poisson's equation •

$$\frac{\partial \rho}{\partial t} + \nabla \bullet \mathbf{j} = \dot{\rho}$$
Charge continuity
$$\mathbf{j} = \sigma \mathbf{E} = -\sigma \nabla \phi \qquad \sigma = \sigma_0 + k_p D^{\Delta}$$
Ohm's Law with Dose Enhanced Conductivity
$$\nabla \bullet \varepsilon \nabla \phi = -\rho \qquad \varepsilon \Rightarrow \kappa \varepsilon_0$$
Poisson's equation

- Can be combined into a single equation •
 - Useful in 1-D codes

Less practical for 3-D code because the boundary conditions become too complex

Used to compare timescales

$$\frac{\partial}{\partial t} \nabla \bullet (\varepsilon \nabla \phi) + \nabla \bullet (\sigma \nabla \phi) = -\dot{\rho}$$



- Environment deposits charge and enhances conductivity Electrons from the environment are deposited in the dielectric Electrons from the material are promoted into the conduction band
- Grounded conducting external layer reduces charging Electric field reduced by a factor of 2 Peak potential reduced by a factor of 4





1-D Analytical Solution for Uniform Charging

• Charge deposition and conductivity independent of position or time

$$\kappa \varepsilon_0 \frac{\partial^2}{\partial x^2} \frac{\partial \phi}{\partial t} + \sigma \frac{\partial^2 \phi}{\partial x^2} = -\dot{q}$$

Grounded Surfaces

$$\phi(x,t) = \frac{\dot{q}\ell^2}{2\sigma} \frac{x}{\ell} \left(1 - \frac{x}{\ell}\right) \left(1 - e^{-\frac{\sigma t}{\kappa \varepsilon_0}}\right)$$

$$\phi_{\max} = \frac{\dot{q}\ell^2}{8\sigma}$$

$$\dot{\phi}_{\max} = \frac{\dot{q}\ell^2}{8\kappa\varepsilon_0}$$

$$\tau_0 = \frac{\kappa\varepsilon_0}{\sigma}$$

$$E_{\max} = 4\frac{\phi_{\max}}{\ell}$$

Analytical formula quite accurate for hard spectra Coaxial results close to those for slab geometry



Formula for uniform deposition in cable inner dielectric compared with potential calculations using spatially dependent deposition and dose





Calculation of a thin circuit board with one or more grounded metal • traces and a single ungrounded area of metallization. The circuit board is suspended inside a grounded metal chamber.





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Finite Difference Scheme For Spatial Potentials

• Basic equation in 1-D $\kappa \varepsilon_0 \Rightarrow \varepsilon$

$$\frac{\partial}{\partial x}\varepsilon\frac{\partial\phi}{\partial x} = -\rho$$

• Finite difference formulation

$$\Delta x_{i+\frac{1}{2}} \equiv x_{i+1} - x_{i}$$

$$\Delta x_{i} \equiv \frac{1}{2} (x_{i+1} - x_{i-1})$$

$$\frac{1}{\Delta x_{i}} \left(\mathcal{E}_{i+\frac{1}{2}} \frac{\phi_{i+1} - \phi_{i}}{\Delta x_{i+\frac{1}{2}}} - \mathcal{E}_{i-\frac{1}{2}} \frac{\phi_{i} - \phi_{i-1}}{\Delta x_{i-\frac{1}{2}}} \right) = -\rho_{i}$$

$$\mathcal{E}_{i+\frac{1}{2}} \frac{\phi_{i+1} - \phi_{i}}{\Delta x_{i+\frac{1}{2}}} - \mathcal{E}_{i-\frac{1}{2}} \frac{\phi_{i} - \phi_{i-1}}{\Delta x_{i-\frac{1}{2}}} = -\rho_{i}$$

$$\mathcal{E}_{i+\frac{1}{2}} \frac{\phi_{i+1} - \phi_{i}}{\Delta x_{i+\frac{1}{2}}} - \mathcal{E}_{i-\frac{1}{2}} \frac{\phi_{i} - \phi_{i-1}}{\Delta x_{i-\frac{1}{2}}} = -\rho_{i}$$

• Standard 7 point difference operator in 3-D



- Time derivative of the potentials •
- Assume exponential time dependence •

$$\phi(t) \approx (1 - e^{-t/\tau})\phi_0$$
$$\frac{\partial}{\partial t} \nabla \bullet (\varepsilon \nabla \phi) + \nabla \bullet (\sigma \nabla \phi) = 0$$
$$\tau \approx \frac{\varepsilon}{\sigma} \approx \frac{10^{-11}}{10^{-16}} \approx 10^5 \, s$$

$$\frac{\partial \rho}{\partial t} + \nabla \bullet (\sigma E) = \dot{\rho}$$

Since the conduction timescale is so long, conduction is treated • explicitly



Finding Floating Potential in Time

Numerically calculate derivatives • of charge and current with respect to floating potential

Floating Potential solved for • implicitly

$$\begin{split} V^{t} &= V_{0} + \Delta V \\ Q^{t} &= Q^{t-1} + \Delta t \ (I^{t} + \dot{Q}) \\ \frac{dI}{dV} \approx \frac{I_{1} - I_{0}}{V_{1} - V_{0}} \\ \frac{dQ}{dV} \approx \frac{Q_{1} - Q_{0}}{V_{1} - V_{0}} \\ I^{t} &= I_{0} + \Delta V \ \frac{dI}{dV} \\ Q^{t} \approx Q_{0} + \Delta V \ \frac{dQ}{dV} = Q^{t-1} + \Delta t \ (I_{0} + \Delta V \ \frac{dI}{dV} + \dot{Q}) \\ \Delta V \left(\frac{dQ}{dV} - \Delta t \ \frac{dI}{dV}\right) = Q^{t-1} - Q_{0} + \Delta t \ (I_{0} + \dot{Q}) \\ \Delta V = \frac{Q^{t-1} - Q_{0} + \Delta t \ (I_{0} + \dot{Q})}{\left(\frac{dQ}{dV} - \Delta t \ \frac{dI}{dV}\right)} \\ I^{t} &= I_{0} + \Delta V \ \frac{dI}{dV} \\ Q^{t} &= Q^{t-1} + \Delta t \ (I_{f}^{t} + \dot{Q}) \end{split}$$



First Test Case

Solution of simplified Poisson's equation in a unit cube ٠



$$\varepsilon = 1$$

$$\rho = 1$$

$$\ell = w = h = 1$$

$$\nabla \bullet (\nabla \phi) = -1$$



Second order accurate calculation of electric fields at Circuit Board ۲ surfaces require equal zone sizes across interface.

Integral of electric fields used to determine charge on grounded metal and potential of floating metal

Accuracy effects the usefulness of the calculations

$$\Delta x_{1} = d$$

$$\sum_{i=1,n} \Delta x_{i} = \ell$$

$$\Delta x_{i+1} = \alpha \Delta x_{i}$$

$$\sum_{i=1,n} \Delta x_{i} = \Delta x_{1} \sum_{i=1,n} \alpha^{i-1}$$

$$= \Delta x_{1} \frac{\alpha^{n} - 1}{\alpha - 1}$$

$$\frac{\alpha^{n} - 1}{\alpha - 1} = \frac{\ell}{\Delta x_{1}}$$

$$\alpha_{i+1} = \left(\frac{\ell(\alpha_{i} - 1)}{\Delta x_{1}} + 1\right)^{\frac{1}{n}}$$



• Test Case Solution is assumed to be a product of parabolas

This determines the right hand side $\phi(x, y, z) = xyz(1-x)(1-y)(1-z)$ $\frac{\partial^2 \phi}{\partial x^2} = -2yz(1-y)(1-z)$ $\nabla z (\nabla \phi) = 2yz(1-y)(1-z)$

$$\nabla \bullet (\nabla \phi) = -2yz(1-y)(1-z) - 2xz(1-x)(1-z) - 2xy(1-x)(1-y)$$





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Tests with Charge Deposition in Dielectric

• Uniform charge density

$$\rho = 10^{-4} C m^{-3}$$

$$\kappa = 1$$

$$\Delta E = \frac{\rho h}{\kappa \varepsilon_0} = 1.81 \times 10^4 V m^{-1}$$

$$\Delta E_{code} = 1.79 \times 10^4 V m^{-1}$$

 $h = 1.6 \times 10^{-3} m$





200 100



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Tests with a Grounded Trace

- Grounded trace amplifies Electric fields $\Delta E_{charge} = 18,000 \text{ V/m}$ $\Delta E_{plate} = 36,500 \text{ V/m}$
- Field polarity changes ٠
 - Positive image charge on the plate
 - Potential has a saddle point in front of plate









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Potentials Along Board with Trace





Potential difference between CB surface and CB max Error $\sim 3\%$ •

$$\Delta \phi_{\kappa=1}^{CB} = 3.60V$$
$$\Delta \phi_{\kappa=3.5}^{CB} = 1.005V$$
$$\frac{\Delta \phi_{\kappa=1}^{CB}}{\Delta \phi_{\kappa=3.5}^{CB}} = 3.58$$

Parallel plate capacitor – accuracy $\sim 4\%$ • part could be fringing fields Center Efield error < 1%

2

$$\begin{split} h &= 1.6 \times 10^{-3} \ m \\ \rho &= 10^{-4} \ C \ m^{-3} \\ w &= 0.12 \ m \\ \ell &= 0.25 \ m \\ Q &= 4.80 \times 10^{-9} \ C \\ \frac{Q}{2} &= 2.40 \times 10^{-9} \ C \\ \frac{Q_{code}}{2} &= 2.07 \times 10^{-9} \ C \ 1^{st} \ order \\ \frac{Q_{code}}{2} &= 2.30 \times 10^{-9} \ C \ 2^{nd} \ order \end{split} \qquad h &= 1.6 \times 10^{-3} \ m \\ \rho &= 10^{-4} \ C \ m^{-3} \\ \kappa &= 3.5 \\ E_{trace} &= \frac{1}{2} \times \frac{\rho \ h}{\kappa \varepsilon_0} = 2.58 \times 10^3 \ V \ m^{-1} \\ \Delta E_{code} &= 2.32 \times 10^3 \ V \ m^{-1} \ 1^{st} \ order \\ \Delta E_{code} &= 2.58 \times 10^3 \ V \ m^{-1} \ 2^{nd} \ order \end{split}$$



Parallel plate conduction test • Charge on Traces -5.83028E-07 5.86843E-07 Current to Traces 1.87500E+04 -1.87500E+04 Area of Traces 3.00000E-02 3.00000E-02

$$h = 1.6 \times 10^{-3} m$$

$$\sigma = 1 \ \Omega^{-1} m^{-1}$$

$$\Delta \phi = 1000V$$

$$E_{trace} = \frac{\Delta \phi}{h} = \frac{1000}{1.6 \times 10^{-3}} = 6.25 \times 10^5 V m^{-1}$$

$$j = \sigma E = 6.25 \times 10^5 A m^{-2}$$

$$A = \ell \times w = 0.25 \times 0.12 = .03m^2$$

$$I = A \ j = 1.875 \times 10^4 Amps$$

$$I_{code} = 1.875 \times 10^4 Amps$$



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Circuit board 12cm x 25cm x 1.6mm Similar dimensions to Leung test article Floating 5cm x 5cm trace Located (2.5cm, 2.5cm) from corner Ground trace 20cm x 0.5cm Grounded Located (1cm,1cm) from corner No Ground plane TO STORAG SCOPE TO STORAGE SCOPE TRANSIENT DIGITIZER OR 0 (8) TRANSIENT DIGITIZER Floating ELEMENTS PLATED Ð THROUGH HOLE TO STORAGE -D SCOPE OR TRANSIENT DIGITIZED Test Case Circuit Board has Large Areas (a) Board A. of Dielectric and no Ground Plane



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30 Minute Charging Test Case

- Arc Discharge Module calculates flow of image charges . assuming the floating metal connects to ground
- Arc module has no mechanism for releasing charge store in the ٠ dielectric
- 1 hour min charging at 4 picoamp/cm² ٠
- Floating potential 67 kV ٠

Beam Current Density (A/m2) 4.00000E-08 Phi Max -9.00E+04 1800.0 -67082.3 -2.503E-08 -1.032E-15 it, t, Vf, Of, dO 1 it, t, Vf, Qf, Curr 0 0.0 0.0 0.000E+00 0.000E+00 1800.0 -67082.3 -2.503E-08 -1.536E-13 it, t, Vf, Of, Curr 1 Arc to ground on trace 2 Charge on Traces 9.83345E-08 1.22306E-07 Arc image charge flow 1.473322E-07 after arc Phi Max -8.30E+04

28





CB IESD Calculations Show Additional Grounded Metallization Reduces Peak Potentials and Fields

- **Electron Beam Charging** 850 keV $4 \text{ picoamp}/\text{m}^2$ 30 min charging
- Floating Metal with Strip

Metal Floating Potential -67 kV Arc image charge flow 1.5E-07 C Peak Potential in Dielectric -90 kV

Beam Current Density (A/m2) 4.00000E-08 Phi Max -6.08E+04 it, t, Vf, Qf, dQ 1 1800.0 -55587.8 -2.505E-08 -3.026E-16 it, t, Vf, Qf, Curr 0 0.0 0.0 0.000E+00 0.000E+00 it, t, Vf, Of, Curr 1 1800.0 -55587.8 -2.505E-08 -1.654E-13 Arc to ground on trace 2 Charge on Traces 6.59049E-08 1.04179E-07 1.94866E-07 Arc image charge flow 1.292264E-07 after arc Phi Max -5.72E+04

Floating Metal Large Grounded Metallization Metal Floating Potential -56 V Arc image charge flow 1.3E-07 Peak Potential in Dielectric -61 kV

Potentials in Dielectric Reduced by 32%

Fully Charged

After Arc





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Ground Plane Reduces Charging by 97%

- Floating Potential -1500 V
- Same as 1-D calculation

Beam Current Density (A/m2) 4.00000E-08 Phi Max -1.49E+03 it, t, Vf, Qf, dQ 1 1800.0 -1488.7 -2.430E-08 4.195E-17 it, t, Vf, Qf, Curr 0 0.0 0.0 0.000E+00 0.000E+00 it, t, Vf, Qf, Curr 1 1800.0 -1488.7 -2.430E-08 2.484E-13 Arc to ground on trace 2 Charge on Traces 2.13102E-08 5.01517E-08 6.76596E-07 Arc image charge flow 7.445453E-08 after arc Phi Max -1.01E+03





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Conclusions

 CB_IESD code can resolve circuit board lateral and internal dimensions 2nd order accurate algorithms
 Varified by comparison with analytical solutions

Verified by comparison with analytical solutions

• Calculations performed for geometry similar to pre-Galileo circuit board IESD tests

Sparsely populated circuit board Only one floating trace

- Results show that 3-D potentials in general much larger than those predicted by 1-D models
- CB_IESD code will be used to help determine design guidelines and to extrapolate laboratory test results to expected Jupiter radiation belt environments